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CONTRACT NO. AFOSR-83-0553

AIR FORCE OFFICE OF SCIENTIFIC RESEARCH BULLING AIR FORCE BASE D.C. 20332

IN SITU THIN FILM MEASUREMENT

Final Report

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September 1. September 1. istribution unlimited.

December 1984

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orating as its dispersive element and	ha CCD array to collect the data. All data is
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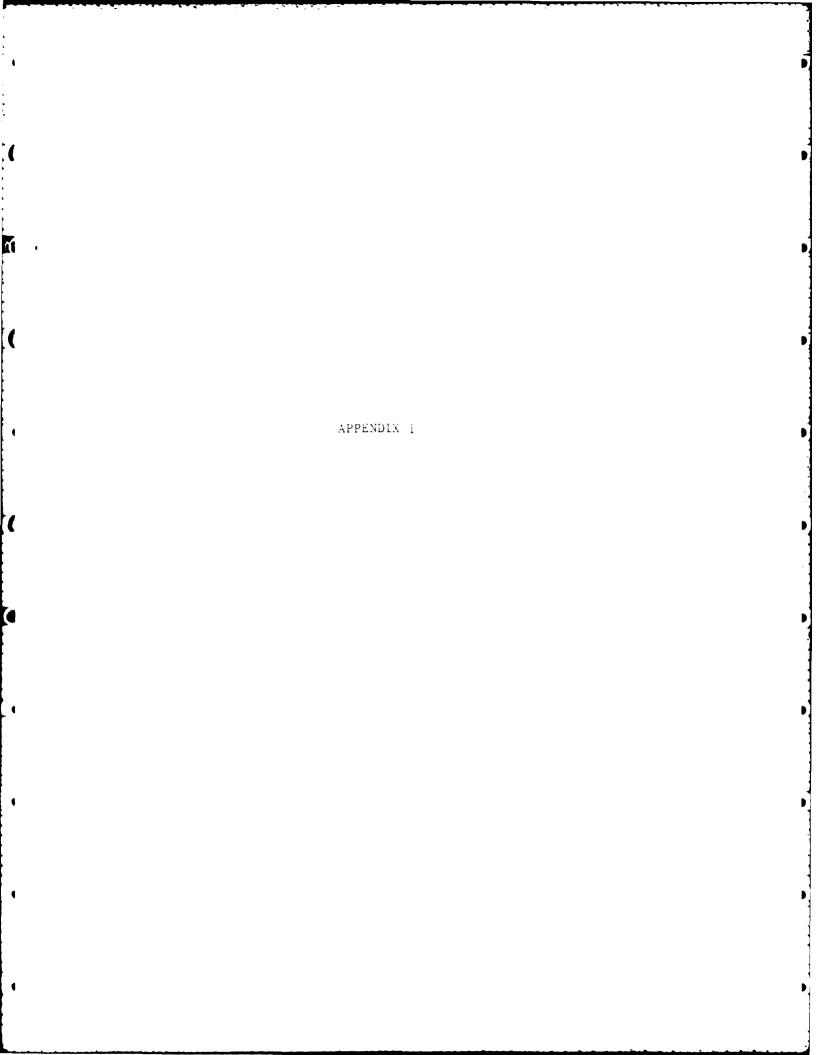
F.J. Jan Milligen, Benthand Boyand, Michael F. Jacobson. James Mueller, Foss Potoff, Richard L. Shoemaker, H. Angus Macleod

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arphi scanning monohromaton system for the monitoring of this film decosition in a box coaten is described. The system employs data From both a quantz priestal oscillaton and a wide band thansmission scentromeren. The spectrometer uses a holographic grating as its preparative element and a CCO annay to collect the data. Hill data is sent to a michocomputer where the information is displayed, stored, and analyzed. Sevenal applications, including measurement of optical constants of inhomogeneous films and characterization of molature adsorption, are discussed.

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#### Introduction

The objective of this contract was the supporting of a Post-Doctorate Assistant, Dr. Bertrand Bovard, from the Ecole Nationale Superieure de Physique, Marseille, France, for a stay of one year at Optical Sciences Center to assist in the development of a rapid-scanning spectrometric system for in situ measurements on optical thin films. Dr. Bovard had been awarded his doctorate in Marseille for work on this topic.

## Monochromator

The measuring system was largely constructed with the help of two DARPA contracts, one monitored by NWC, China Lake, and the other by NOSC, San Diego. It consists of a concave holographic grating with a CCD array detector in the spectrum plane. The grating was specifically designed to be used with array detectors and the spectrum plane is flat over the width of the detector. A spectral range from approximately 450 nm to BOO nm is scanned by the system.

Details of the system are described in Appendix 1, the draft of a paper that is being submitted to Applied Optics

## Thin Film Measurements

Most thin films are inhomogeneous, especially the refracting oxides. Optical inhomogeneity is difficult to measure accurately after deposition. Although the presence of inhomogeneity can readily be detected, the results are insensitive to the specific refractive index profile.

Thus, if we are to have information about the variation of refractive index through the film, additional information is necessary and in situ measurements made in the coating plane during deposition) are particularly attractive. We must make the assumption of film stability, that is, that the portion of the film already deposited remains recognized whose turbed material is added. Results that obviously constructed as simple a middle unstable films. We find that well ownide in regularized inguisted titania films are usually stable but that the modern corrections are with oxygen deficiencies can show unstable modern.

Further product to  $\mu$  is such measurement system and of the techniques for the Park content of Appendices I and 2, the texts of two papers that are tell  $\mu$  is a function of Applied spin  $\sigma$ .

#### INTRODU**CTION**

After an optical filter has been satisfactorily designed, it must be implemented in a production fact ity. For anything but the simplest of multi-aven stacks, this involves the selection of the proper process parameters for a specific set of materials in a particular vacuum chamber. The length of time required to control this process fully desends upon the efficiency and fidelity of the monitoring techniques available to the operator. In general, there are two means of monitoring film deposition:

- Indical monitoring: This technique is more appropriate in realizing coatings consisting of quanterwave layers by detecting the extrema of transmission or reflectance at a particular wavelength. This tetrod is extremely stable for the control wavelength and only slightly less stable around it. Therefore, it is used for coatings besidned for performance over a narrow wavelength region.
- name inequence of a quantz cristal, it is possible to determine the mass deposited or ats surface; assuming densities for the film materials, one can compute the thickness of the lawers, with this technique one can monitor lawers of any thickness with high sent surface; since it does not include any measurements in the lottical pentimance, it does not include any measurements in the lottical pentimance, it does not provide the stability of definity data.

In this paper, we will describe a scanning monochromator system which employs both of these techniques in parallel with the added advantage of measuring the optical transmission of the sample of a wide wavelength range. We continue by discussing relevant testures of the system and considering some of its applications.

#### 1. IMPLEMENTATION

It is appropriate to begin by mentioning that our system was inspired by one built by the group led by Felletien in Manseilles, Fhance. 2.3 But scanning monochromator system was intended to suggest the pagabilities of a Balzens 760 box coater, which was belinered with an automated process controller (Balzens Model KB doubles on a quantz crystal monitor and a second, unautomated, single was elergth optical monitor (Balzens Model 384 218). The end of the first subsistem was left intact; the second subsistem was replaced with our wideband optical monitoring portion of the first subsistem.

Found to as a descript, electric diagram of the scanning monder on match system. To ensure that the signs ineaching the CCD annay is specified, the program Balgers oght scance was neplaced with a runch magnitude, CRR withogsteneral ogen lamp. This source met the required chords are given as atunate the perectors and such the required chords are given as single (RRM) neterence one for an electric scand of the control of the shown .

Distraviorer negation. To solve this phoblem, we are cunnently neplations the tengster-halogen with a kenon and lamp which will have both a flatter spectrum and output in the distraviolet, shown in Figure 25.

immediately adjacent to the sounce, the beam is modulated by a foun sector choosen, union also provides a neverence signal to the other mapplituen, part of the detector electronics beyond the deficient. After the chippen, the light is projected by a lens into the chamber via a point in the baseplate, through the witness, on severence sample, and back but through a point in the chamber hoof. For some experiments, a notating finture moves more than one sample through the monitor beam, permitting in situ coating companisons. Figure 3 deplots the overall annangement of the scanning monochromation with monochromatic with respect to the original box coaten.

Hatter exiting the chamber, the beam is turned by a a at minnon. In the haun scanning monochromator optics. First, it is netocused by a lens onco a slin, which is 1 cm magn and abordinate 120 km de. Hatter the slit, the beam encounters the dispensive element of the slinks for contrate will be made to spensive element of the slinks for contrate will be personally net either the slinks for each mand designed to dispense with into a mention, a second of second to dispense with into a mention and second of slinks for each of the slinks for each of the grant with a monochast potential between the slinks of some the few will be slinks for each other as a first second of the grant with a grant with a slink of the slinks for each of the grant will be slinks for each of the slinks of

that bounds  $\frac{4}{2}$  A view of this part of the monochromator appears in Figure 4.

The GCC annual consists of 1718 elements; our signal processing electronics as mages sets of ten adjacent elements, providing us with 173 data points. These data levels are sent on to a dedicated 1869-81, which records the data on five inchifloppy disks and dish places them or an emper video monitor for heal time feedback to the contraction. He the same time, information from the original choicess controller, based on the quantz crystal monitor, is sent through an interface module to the 18M-PC.

which are showing now the computer handles the data appears in Figure 5. The IBM-PD incomponates a Techan AZB board, which injects (2-bit data +nom both the quantz chustal monitor and the CCD array. Helthough the electronics are capable of numbing at a nate of four spectra per second, we generally take one spectrum every three deconds. This is builte adequate, since at our typical deposition notes primary to exides), we deposit ten to twent Angstroms of material or three seconds. The potential for data nates at least and there is ragnificate region. The potential for data nates at least and there is nationally a ragnificate region. Table 1, below, submaribes incomparing that the attentions of the scanning monotonisation monitor.

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Teadings other than those given by the absorption lines the waver length is determined by linear interpolation between Known points. We estimate an accuracy of 2 to 4 nm over the range we have tested with available spectral line sources.

## 3. HEPLICHTIONS

Sevenal examples of applications for the scanning monoconomator monoton follow:

- . A sequence of thansmission spectra for each run can be stored for after analysis of the effects of various process parameters. A leak comble-density 5.25 inch disk can accommodate about 50 minutes of continuously monitored spectral data.
- 2) The wideband transmission spectra that appear on the monitor one ide the piert operator with a much broader view of coating protones; should problems arise, the operators can base their decisions during deposition on a larger data base.
- 3 Figure 2010 and 2010 e in situ benow: a testing and observation of the continuous remoting them that the available and e in this testing all 11. Supposes in Figure 2: 11 examines the effect of water adsorption on a tilter.

Gength at a particular thickness. 🤊

#### 4. ACKNOWLEDGMENTS

The decelopment of our scanning monochromator is stem was inspined by a proneening system constnucted at the Laboratoine d Istrage de l'Essle Nationale Superieure de Physique in Manseille. France, led by E. Pelletier and including F. Flory, A. Fornier, and F. Richten. The other member of that group is among the one of this paper; we were fontunate enough to have B. Bowant as a postdoiting scientist for one year at the Optical Sciences ......................... U.s.t had an extreme visithulating intidence on the construction and completion of the instrument. The Air Force Office of Scientific Research [AFISR] provided salary support for his year in Anizona, we vol dia so like to thank T. D. Ferguson and Fuse'' Ohipman of the upthical Educations Center for their helpful discussions. M. Dagood skill to the executed the togines. The also would like to thank the orrense Hovanced Research Phojects Agency (CHRPA) for their generous support of pages then to his nesearch through a three-wear contract tion to her is the NAPA weapons letter.

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A provided it is reasonably thick and from the specific provided it is reasonably thick and from the appreciable index contrast at its boundaries, can be represented to the characteristic matrix.

- + with  $n_{\rm out}$  is the index at the outer surface of the film  $n_{\rm pos}$  is the index at the inner surface of the film, and is the phase thickness.
- $\sim$  assume that the absorption is very small, the same matrix can be
- . We have the extinction coefficient included in 5 only so that  $(x,y) = (x+y)^{2} + (x+y)^{2}$
- $\text{ and } r \text{ is the mean injex of the film (i.e. } \frac{1}{n} = \frac{1}{d} \int_{0}^{r} n(z)dz),$
- $\text{Proposed extraction perficient (i.e. } \overline{k} = \frac{1}{d} \frac{\sqrt{d}}{\sqrt{d}} k(z)dz),$
- on in the ⊷energian and
  - e to energy of the lavet.
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In the case of negligible extinction coefficients the derivation of the retractive index can be achieved using an admittance circle method based on transmission measurements during the growth of the layer<sup>5</sup>. But since our interests lie more in slightly absorbant materials such as oxides, we have developed a technique inspired by the envelope method described by Manifacier et al (6). We have used an inhomogeneous model of a thin film to derive the refractive index and the extinction coefficient profiles.

# II... Envelope method in the inhomogeneous case

Manifacier et al<sup>6</sup> have fully described the envelope method in the amiting case of an homogeneous thin film where only transmission phasitements are required for the derivation of n and k. A presentation to an innomogeneous model was presented by Arndt et al<sup>7</sup> to derive the optical constants from measurements of reflectance and transmittance. In these studies reflection and transmission are answered as functions of wavelength and their envelopes are used to associate the optical constants. To obtain the profiles of the optical constants, as in this study, we considered the envelopes of the curve of transmittance as functions of thickness for a chosen wavelength. We work able to obtain the dispersion by applying the same method to a trace of wavelengths.

\*\* The demonstrate the principle of the method and give the analytical features on the optical constants.

### I. Introduction

The refractive index and the extinction coefficient of a thin film depend upon the conditions of deposition and as a consequence upon the structure of the film itself. In the case of oxides, inhomogeneities are largely due to the film's columnar structure and to the variations in degree of oxidation throughout the layer. The derivation of their profiles as a function of thickness is difficult once the layer has been deposited. Furthermore, most techniques developed to measure the refractive index are carried out under atmospheric conditions. Exposure of a film to the air modifies its optical properties: the voids existing in its structure tend to adsorb moisture and an oxidation process may occur for a suboxidized layer, changing the refractive index and the extination coefficient.  $^{2,3}$ . Therefore a technique taking into account the evolution of the transmission of a layer growing in vacuo has great advantages. To achieve such measurements we have used a scanning monocaromator system4 which provides us with the transmission over the Wisible spectrum versus time, during deposition. Using these values we There developed a technique for deriving the profiles of the optical - 58% ents. After a verification of the optical constants determination the Coline by computer simulation, we have applied the method to various layers of titabium dioxide. This technique can then be used as a means of minitizing the effect on the optical constants of a change in any of the parameters used for the coating process.

The determination of the profile of the optical investigation of an investigation of the profile.

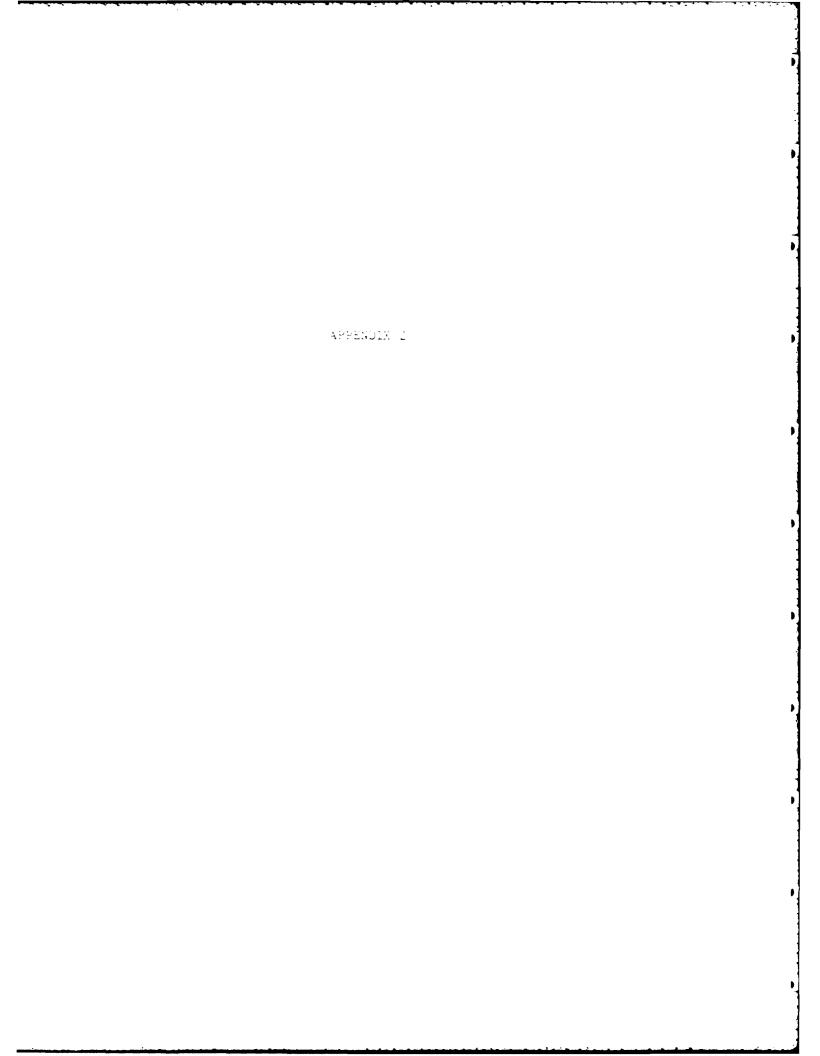
Optical Constants derivation for an inhomogeneous thin film from in situ transmission measurements

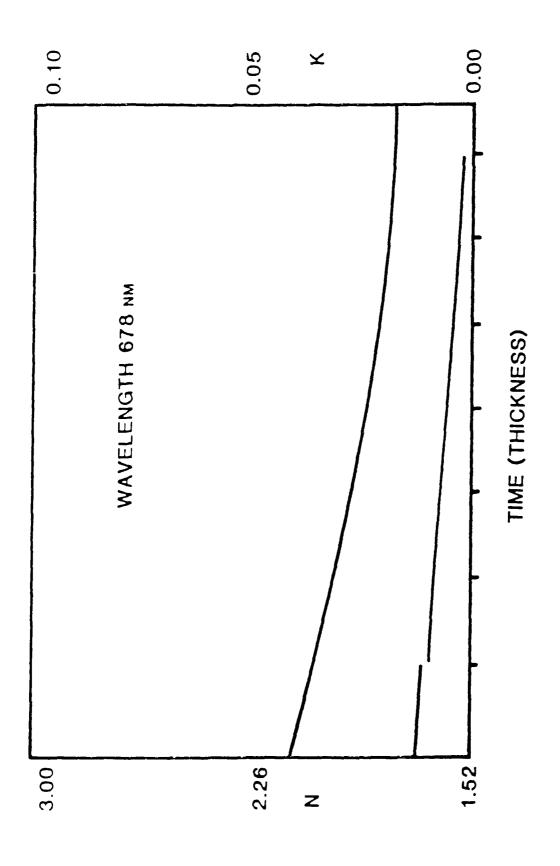
B. Bovard, F.J. Van Milligen, M.J. Messerly, S.G. Saxe, H.A. Macleod

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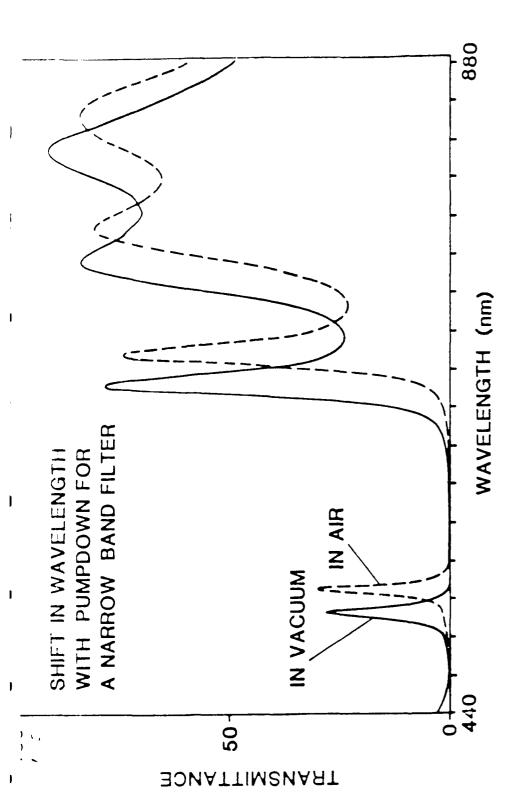
# AssIPAII

The optical constants of a thin film depend upon the structure of the film itself. A technique, based on transmission measurements carried out in vario, has been developed to derive the profiles of the refractive today and extinction coefficient. The interpretation of the profiles gives information on the layer structure in vacuo. The technique can be used as a means of monitoring the variations of the optical constants with changes in the deposition parameters. This paper presents the technique, which is based on an envelope method, and gives some exception of a results.

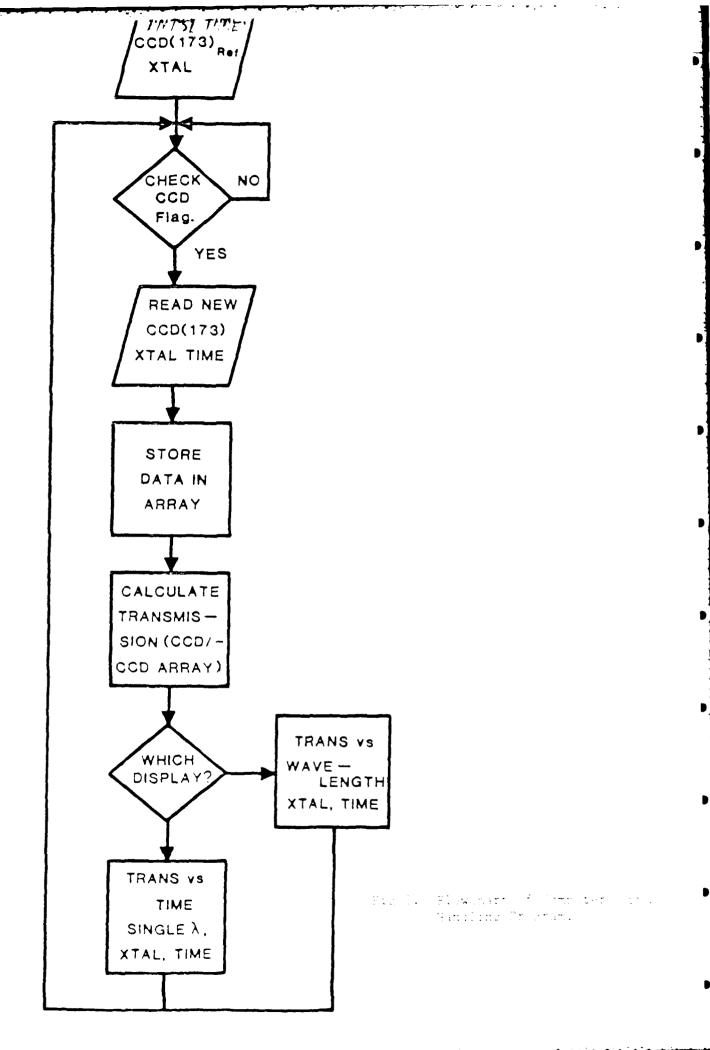


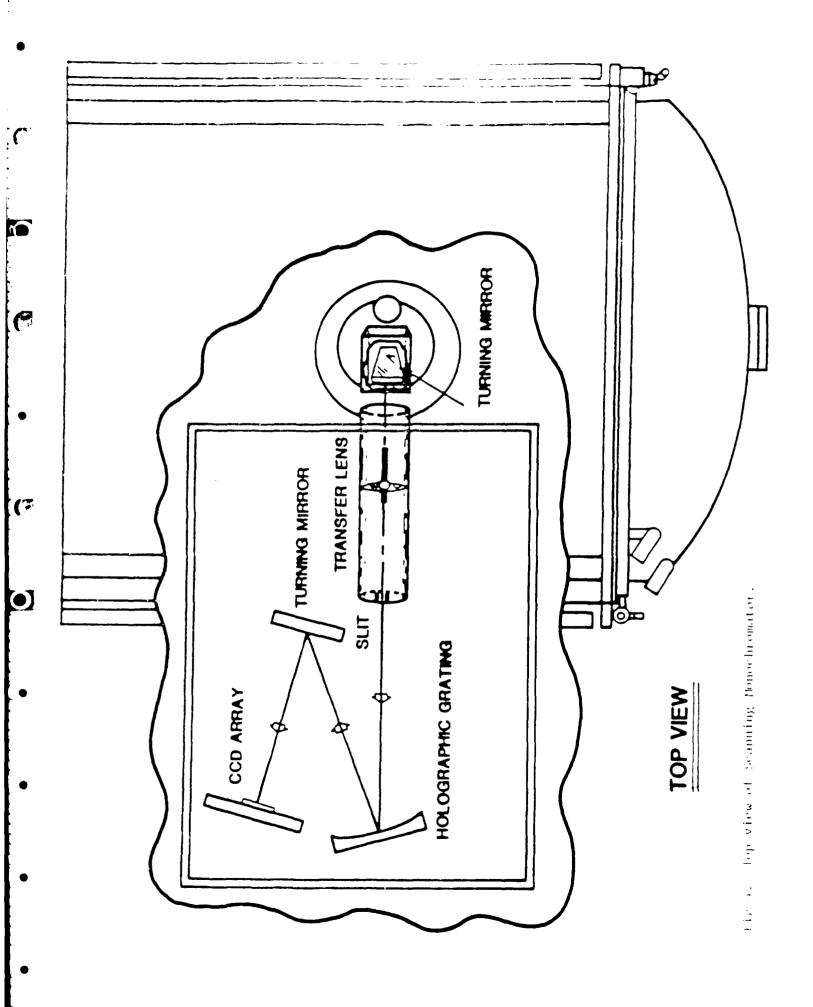


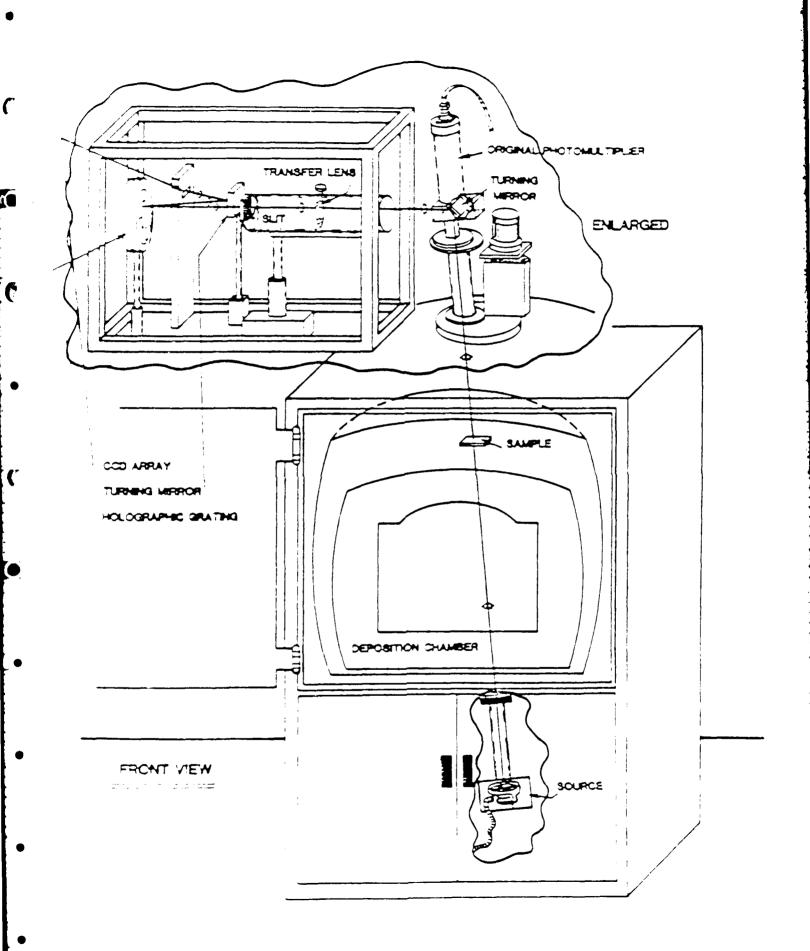
Variation of optical Constants of TiO  $_2$  film as the film is being deposited. Upper curve corresponds to  $n_\star$  lower curve to  $k_\star$ F1R 7.



example of Mater Adsorption in a 1102, SiO2 Labry Perot Filter







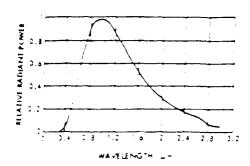
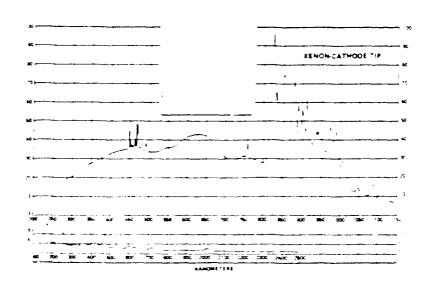
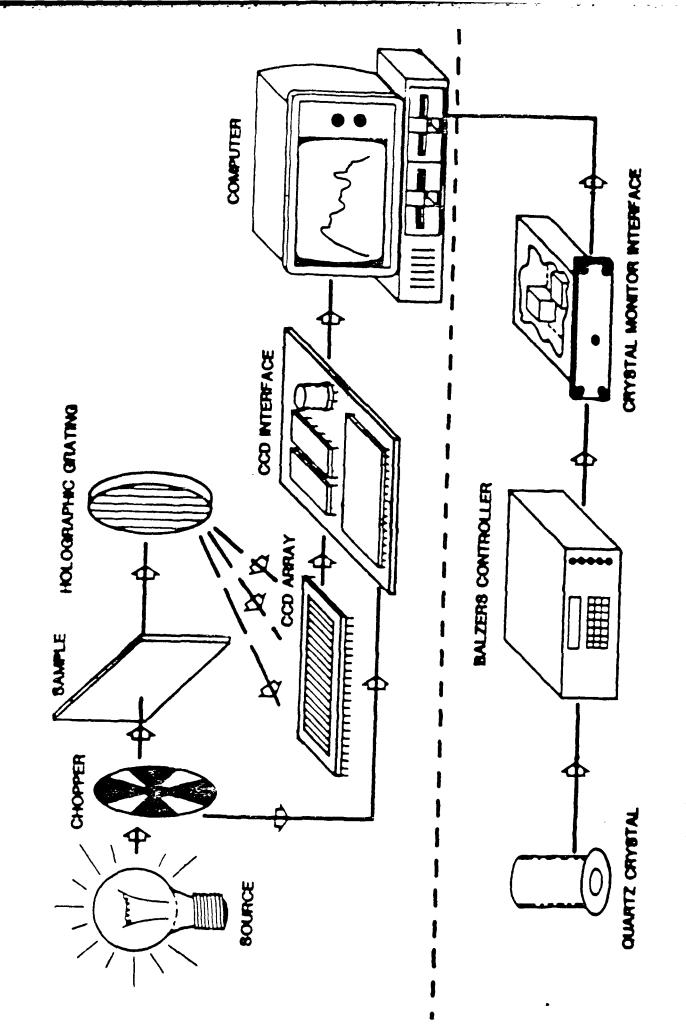


Fig 14. Sweetral Profile of Tungsten Halogen Lamp.





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Lig L. Scanning Monochromator Flow Diagram.

# FIGURE CAPTIONS

•	Scanning Monochromator Flow Diagram
la.	Spectral Profile of Tungsten Halogen Lamp
25.	Spectral Profile of Xenon Arc Lamp
3.	Appearance of Scanning Monochromator system
<b></b>	Top view of Scanning Monochromator
5.	Flowcnart of Computer Data Handling Program
÷.	Example of Water Adsorption in a TiO2, SiO2 Fabry-Perot Filter
7.	Variation of optical constants of $\text{Ti}\theta_2$ as the film is being
	deposited. Upper curve corresponds to n, lower curve to k.

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# TABLE 1: SYSTEM PERFORMANCE

have ength Pange	વેચીએ − કુંગુંછે ત∼
Wave ength Resolution	2 nm
R <b>e</b> so≒ling Power	300
Eterab of Bystem	1 x :0 <sup>−3</sup> cm <sup>2</sup> -er
Minimum Thansmission	2%
Signs Level of CCD	70% of saturation at ±50 nm

$$T = \frac{16n_{8}n_{o} n_{in} n_{out} e^{2\delta_{z}}}{C_{1}^{2} + C_{z}^{2} e^{4\delta_{z}} + 2C_{1}C_{z}e^{2\delta_{z}} \cos 2\delta_{1}}$$
where  $C_{i} = (n_{out} + n_{o})(n_{s} + n_{in})$   $C_{z} = (n_{out} - n_{o})(n_{s} - n_{in})$ 

$$\delta_{i} = 2\pi n_{out} \lambda$$
  $\delta_{z} = -2\pi k_{out} \lambda$ 

In the following we shall assume that we are dealing with a high index layer so that C, is negative. Then the two expressions of the envelopes become:

$$T_{max} = \frac{16n_0n_sn_{in}n_{out}e^{2\delta_2}}{(C_1 + C_2 e^{2\delta_2})^2}$$

$$T_{\min} = \frac{16n_0n_sn_{1n}n_{out}e^{2\delta_2}}{(C_1 - C_2 e^{2\delta_2})^2}$$

These two equations are used to determine the outermost index for each instant during film deposition. They are also used to calculate the extinction coefficient at the quarterwave points.

dowever, all these derivations are possible only if we make a very basic assumption about the stability of the layer during deposition. This assumption is simply that the innermost index does not vary during the growth of the film. The profiles of the optical constants can then be derived and considered as functions of thickness instead of time.

We shall not go through the details of the derivation and we shall only give the analytical expressions for the innermost and outermost

refractive index, the geometrical thicknesses and the extinction aperficient profile.

The expression of the innermost refractive index is obtained assuming  $n_{in} = n_{out}$  and d=0 so that:

$$n_{in} = [N+(N^2-n^2_{o}n^2_{s})^{1/2}]^{1/2}$$
 where  $N=\frac{n^2_{o}+n^2_{s}}{2}+2n_{o}n_{s}(\frac{Tmax-Tmin}{Tmax\ Tmin})$ 

The expression of the outermost refractive index is then:

$$n_{\text{out}} = \frac{2n_{\text{in}}n_{\text{s}}n_{\text{o}}}{n_{\text{in}}^{2} - n_{\text{s}}^{2}} = \frac{\text{Tmax-Tmin}}{\text{Tmax Tmin}} + n_{\text{o}} \left[1 + 4n^{2}_{\text{in}}n^{2}_{\text{s}} \left(\frac{\text{Tmax-Tmin}}{\text{Tmax Tmin}}\right)^{2} / (n_{\text{in}}^{2} - n_{\text{s}}^{2})^{2}\right]^{1/2}$$

which is calculable only if we know the innermost index value.

Provided we assume the innermost index is stable we can calculate the profile of the refractive index of an inhomogeneous layer. Note that it requires the knowledge of the substrace refractive index, which can be measured independently, but it does not require the value of wavelength.

We also require the geometrical thickness. Since we are dealing with tow-absorption materials, the extrema of transmission occur when the optical thickness of the layer is a multiple of a quarterwave.

It may the order of the extremum (m=1 indicating the first minimum) the order ponding geometrical thickness is

$$1 = m + \frac{1}{2} \quad \text{where } \frac{1}{2} = \frac{1}{2} \qquad n(z)dz$$

$$= \frac{1}{2} \qquad (3)$$

since calculation of  $\frac{1}{d}$   $\int_0^d n(z)dz$  is impossible, we make an

approximation and write that  $\frac{1}{n} = \frac{1}{t} \int_{0}^{t} n(u)du$  where t is the instant when the extremum occurs.

This is equivalent to assuming that the rate of deposition (change in thickness per unit time) is constant. The assumption is reasonable because our deposition rate is automatically controlled.

With regard to the profile of extinction coefficient we note first that a mean value of the extinction coefficient can be derived each time we teach a new quarterwave:

$$\frac{1}{\kappa} = -\frac{\lambda}{4\pi d} \text{ Log a(d) with a(d)} = \frac{C_1[1-(\text{Tmax}/\text{Tmin})^1/^2]}{C_2[1+(\text{Tmax}/\text{Tmin})^1/^2]} = \exp\left(-4\pi \frac{\overline{kd}}{\lambda}\right)$$

but since the function a is available at any instant during the growth of the layer, we can also calculate its derivative versus time and obtain an expression giving the profile of extinction coefficient.

 $\times z = -\frac{\lambda}{4\pi} \frac{1}{z(z)} \frac{dz}{dz}$  where z is the thickness of the layer.

Because of the derivative, this expression presents some sensitivity to errors but can still be used to obtain an indication of the absorption of the material.

## II.2. Stability of deposition and conclusion

Provided we know the envelopes of a curve of transmission, using these analytical expressions we are able to derive the optical constants. But the necessity of knowing the envelopes as functions of thickness leads us to a very basic assumption concerning the stability of growth of the layer. The envelopes calculated using the measured transmission versus time are usable if they do not shift during the deposition process, which means that an earlier part of the layer is not modified during the deposition of a later part.

It is easy to foresee the importance of having an accurate way of determining extrema of the transmission curves. Their precise estimation, both value and position, demanded that we consider some numerical treatments of the raw data before calculating the envelopes fitting these points. We present in the next section the data processing techniques developed together with a justification of their validity and of the expressions presented above.

# III. Data Progessing and Simulation

100

The envelope computation requires an acturate knowledge of the extremal together with a method to fit carves to these points. It was to ithe possible that the data processing used for the allocation of the envelopes might introduce a blas in the results given by the program of optical constant determination. However, we are able to so world to so the case so that our results are fine that a coefficient.

# III. .. Smoothing the purve of transmission services

Many methods are available for smoothing, but can make the control amount without distorting the curve. For this reason, we decided the affiltering method based on a finite impulse response filter all anates to have a linear phase and an extremely flat low-pass band. We thus avoid any distortion introduced by a nonlinear phase and the attenuation due to a nonflat passband. The filter does still introduce a delay equal to the derivative of its phase versus frequency, but this delay is constant and is corrected in the computation by an entire shift of the gressent design and so we limit our description to demonstrating its application to a real signal in Figs. 1 and 2.

#### . . . . . show.som computation

The entrations of the envelopes are computed by segments. The first or about three points gives a parabola which is used to describe the segment of the cone case perween the first two points. Next the first point the carrier actions, and by the foath point. A new parabola is now

Althorate and used to describe the segment between the second and third course. This operation is repeated until the entire curve is produced.

# III. 3. Verification and precision of the technique

The validity of the expressions for the refractive indices and the extraction coefficient has been checked by some simulations, the results of which are presented here.

A program able to handle variable optical constants has been developed to compute the evolution of the transmission of a coated substrate furing growth of a thin film. The profiles of the optical constants are ted into the program which divides the inhomogeneous layer into a stack of homogeneous sublayers each of thickness lnm. The transmittance is then recorded on disk files exactly as when the scanning monochromator is used. The optical constant determination program is then used to compute the index and estimation coefficient profiles. Their comparison with the original ones verifies the accuracy of the technique. Our goal was also to show it is possible to separate the inhomogeneity of the retractive index from the extinction coefficient. Of the many computations that have been performed we simply show two of the most inattacteristic ones.

The simplest case is that of a homogeneous layer. Taking starting values of n = 2.3 and  $k = 1)^{-3}$ , the optical constants were calculated but two wavelengths 400 and 800 nm and the indices found were to be with the optical value. As foreseen, the efficiency of the

Albulation of the extinction coefficient was not as good, leading to a . \* relative error.

To test the derivation in the case on an inhomogeneous layer, an arbitrary curve of refractive index was chosen to compute the evolution at transmission:  $n(d) = 2 + 0.3 \exp{(-d/200)}$  where d is the thickness of the layer. The extinction coefficient was assumed constant equal to 1.7%. Table , shows the calculated results for two wavelengths. The layers  $\Delta n_{\rm in} n_{\rm in}$  etc. list the error in the determination expressed as a percentage.

ĭ ·

TABLE 1

Wavelength

(mm)	n <sub>in</sub>	$\Delta n_{ ext{in}}/n_{ ext{in}}$	nout	$\Delta n_{out}/n_{out}$	κ Δk/k	
400	2.297	0.15%	2.012	0.09%	1.03x10 <sup>-</sup> , 7%	
800	2.283	1 %	2.025	0.7 %	0-1.7x10 <sup>-3</sup> -	

Results of simulation calculations

These results indicate that we can expect acceptable accuracy in the refractive index profile using this technique. It is important to note that the higher accuracy corresponds to the shorter wavelength. This is due to the greater number of extrema at the shorter wavelength, which provides more information so the envelopes calculated have a more exact position. This inaccuracy of the envelopes leads to questionable values to extinction coefficient for the longer wavelength. These results are transposely true only for the cases considered but they strongly suggest what we can generally expect from this method. The relative accuracy of the refractive index depends also upon the quality of the transmittance measurements: it ranges from LT/T to SAT/T where AT/T is the relative accuracy achieved in the transmittance measurements.

# IV. Experimental results

The optical constant determination has been carried out for titanium closed layers only. We will present the results obtained with two interent layers, the first layer fitting the model used in this derivation and the second being unstable.

The starting material used in our experiments was  ${\rm Ti}_z\theta_z$  evaporated by electron bombardment onto a glass substrate.

For the first layer we consider, the oxygen partial pressure was +... < 1.7% mbar and the inamber temperature varied from 204° to 227°C during the deposition.

The profile of refractive index and of extinction coefficient are plotted in Fig. 3 for the wavelength 678 nm. The thickness of the layer is 670 nm, the inner index is 2.135 and the outermost index 1.794. The layer is inhomogeneous, as expected for an oxide layer, and slightly absorbant.

The correlation between index and extinction coefficient can be interpreted as an increase of the degree of oxidation with the thickness of the layer and as a decrease of the packing density due to a conical form of the columnar structure. It is difficult to choose which has the primary effect.

Fig. - gives the dispersion of the innermost and outermost refractive indices. A high dispersion for the outermost index suggests a more absorbant outer part of the layer.

The layer appears to be stable and therefore our results indicate that it is an inhomogeneous layer showing a decrease in its packing density and a secrease in its oxidation degree in the direction of growth.

We now examine an unstable layer. This layer was deposited in a chamber at a temperature of  $250^{\circ}$ C in the presence of oxygen at a partial pressure of ...  $10^{-1}$  moar.

This atmosphere was intentionally deficient in oxygen compared with the isual conditions for the deposition of titanium dioxide and we expected some absorption in the layer. We are not disappointed as shown fig. 5

extinction coefficient falls with thickness towards a value which could even become negative. This is almost certainly the effect of instability in the exidation of the layer; starting with a high deficiency of oxygen the inner part of the film is gradually exidized as the layer grows. This defeats the technique presented here since the extrema used to calculate the envelopes are imanging with the exidation of the layer and also because we have assumed the innermost refractive index to be constant. The real cirve is impossible to obtain but we can expect that it would present a less innomogeneous profile.

Ather experiments have been carried out to understand the limitations of this method. The instability of the layer can manifest itself by the appropriate of negative extinction coefficients, by thicknesses varying with wavelength or by very misshapen profiles of index. Nevertheless, the application of this technique to stable layers gives very interesting results. These can give information on the structure of the layer in terms of packing density as well as in terms of degree of oxidation. It is also important to know that layers can be unstable and to be able to religious such an instability. Further work is required in this area. We hope that eventually it may be possible to distinguish an instability alse! by a structural reacrangement from a reoxidation of some thermost portions of the film.

### 7. Jonelusion

Inis method has been developed for layers presenting a high index, a small homogeneity, and a small extinction coefficient. It permits the determination of the profiles of the optical constants and the dispersion of index in vacuo provided the assumption of stability is fulfilled. It identifies layers that are unstable. It makes possible the study of the variations of the optical constants with changes in the deposition parameters.

Major support for this work was provided by the Defense Advanced Rusearch Projects Agency (DARPA) through a contract with the Naval Weapons lenter, China Lake. Additional support was also given by DARPA through a contract with the Naval Ocean Systems Center, San Diego. Bovari was supported by the Air Force Office of Scientific Research and Saxe by a fellowship from the U.S. Army Research Office.

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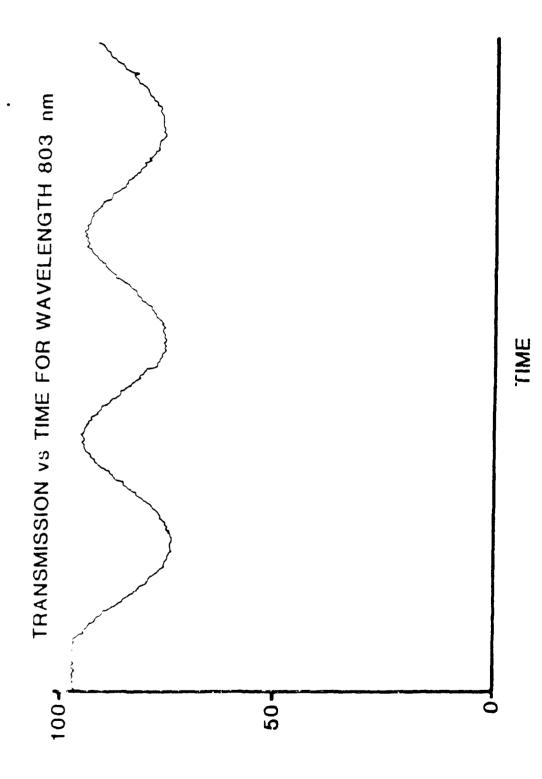
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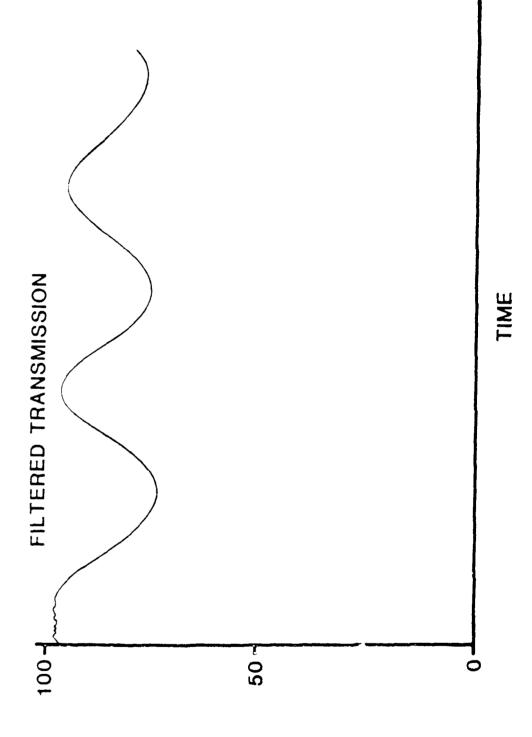
## FIGURE CAPTIONS

- Plot of noisy signal. The extrema are difficult to determine with accuracy.
- After filtering, the extrema have been extracted from the noise without distorting or attenuating the transmission curve.
- Profile of refractive index and extinction coefficient for a stable titanium dioxide layer. (Upper curve represents n, lower curve k).
- -. Dispersion of innermost and outermost refractive index for a stable layer of titanium dioxide.
- 5. Example of result given by the method when applied to an unstable layer. Titanium dioxide layer deposited in an oxygen deficient atmosphere.



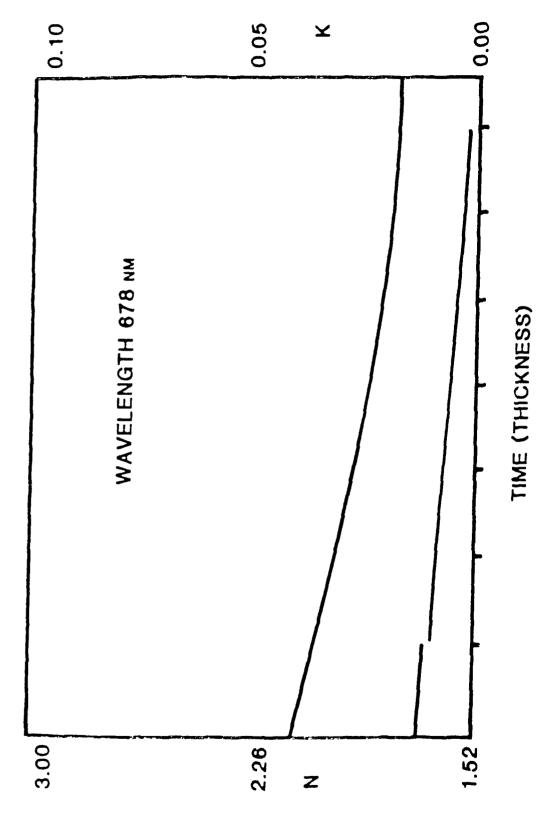
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Fig.1. Plot of noisy signal. The extrema are difficult to determine with accuracy.



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After filtering, the extrema have been extracted from the noise without distorting or attenuating the transmission curve. 118 2.

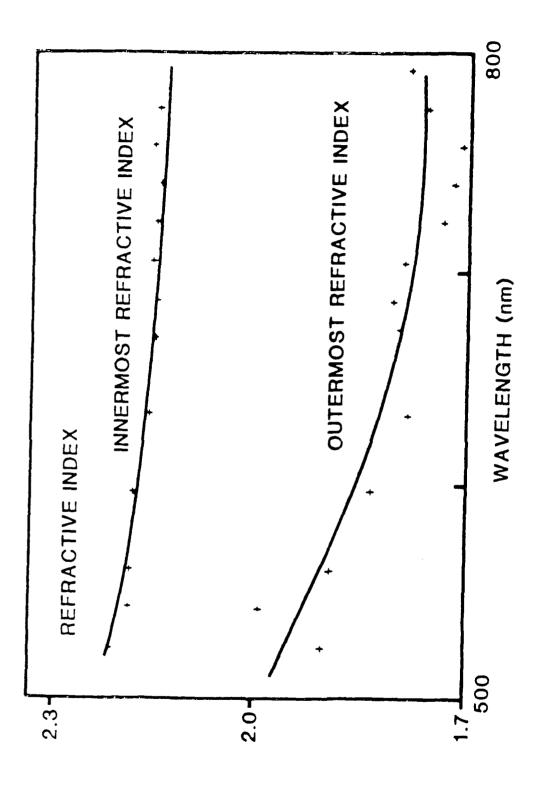


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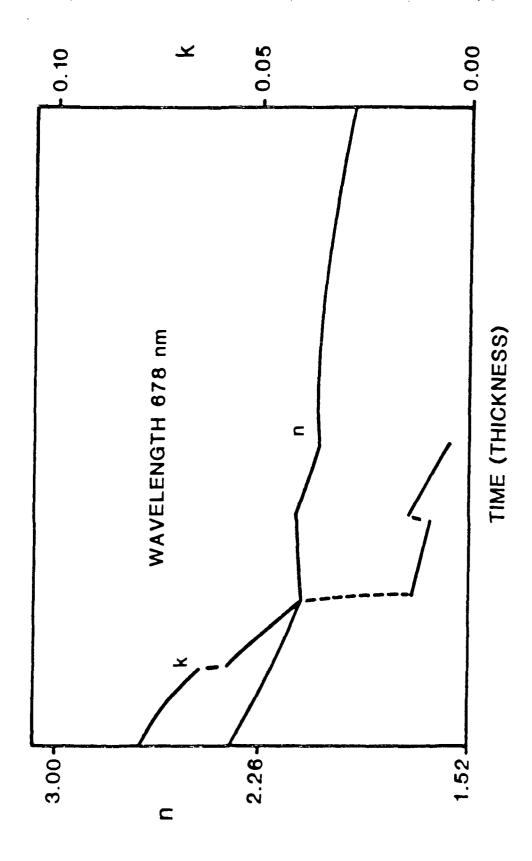
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Profile of refractive index and extinction coefficient for a stable Titanium bloxide layer. (Upper curve represents u, lower curve k). 1.18. 1.



Dispersion of innermost and outermost refractive index for a stable layer of titinfum dioxide. F18 4.



Example of result given by the method when applied to an unstable Laver. Titanium dioxide layer deposited in an oxygen deficient atmosphere. Fig 5.

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